

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yeo, *et al.* Docket No.: TSM03-0760
Serial No.: 10/803,712 Art Unit: 1756
Filed: March 18, 2004 Examiner: Brittany L. Raymond
For: Immersion Fluid for Immersion Lithography, and Method of Performing
Immersion Lithography

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's
Office Action mailed May 2, 2007. Please amend the above-referenced application as follows.